



IFW 2825

PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MARKUS NOPPER
AXEL PREUSSE

Serial No.: 10/602,192

Filed: June 24, 2003

For: METHOD OF FORMING A METAL
LAYER OVER A PATTERNED
DIELECTRIC BY ELECTROLESS
DEPOSITION USING A CATALYST

Examiner: Caridad Everhart

Group Art Unit: 2825

Att'y Docket: 2000.106500/DE0260

Customer No.: 23720

RESPONSE TO OFFICE ACTION DATED OCTOBER 29, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING
37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

November 8, 2004

Date



Signature

This paper is submitted in response to the Office Action dated October 29, 2004, for which the three-month date for response is January 29, 2005.

A fee in the amount of \$582.00 is believed to be due in connection with the present paper. The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0260. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.106500.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

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01 FC:1201
02 FC:1202

\$28.00 DA
54.00 DA